Attorney's Docket 081468-0306369 Client Reference: P-1790.000-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e PATENT APPLICATION of: OOST JEROEN OTTENS ET AL. Confirmation Number: 4455

Application No.: 10/743,272

Group Art Unit: 1756

Filed: December 23, 2003

Examiner: Christopher G. Young

OPTIMIZED CORRECTION OF WAFER THERMAL DEFORMATIONS IN A

LITHOGRAPHIC PROCESS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

FEES

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

i											
	CLAIMS REMAINING AFTER AMENDMENT	PREVIOUSLY		PRESENT EXTRA		RATE			ADDIT. FEE		
TOTAL	40		50	=	0	_x_	\$_	50.00	=	\$	0.00
INDEP.	12		5	=	77	х	\$	200.00	=	\$	1,400.00
FIRST P	RESENTATION	OF M	ULTIPLE	DEP.	CLAIM		+ \$	360.00	=	\$	0.00
TOTAL ADDITIONAL CLAIM FEE										\$	1,400.00
GRAND TOTAL										\$	1,400.00

FEE PAYMENT

Authorization is hereby made to charge the amount of \$1,400.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: March 20, 2007

PILLSBURY WINTHROP SHAW PITTMAN LLF

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